## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| IN RE THE APPLICATION OF                        | )   |
|---|---|
| Andreas Wittmann et al.                         | ) Examiner:   |
| SERIAL NO.: To Be Assigned                      | ) Group Art Unit No.  |
| FILED: Herewith                                 | )   |
| FOR: Anti-Reflection Coatings for Semiconductor | )   |
| Lasers  | I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to "Director of Patents and Trademarks, Washington, D.C 20231, Box: Application" on November 6, 2001. |
|   | Name of person signing Deborah E. Dudek Signature Deborah E. Dudek  |
| AMENDMENT ACCOMPANYING APPLICATION              |   |

Honorable Director of Patents and Trademarks Washington, D.C. 20231

Dear Sir:

It is requested that this application be amended as follows:

## In the Specification

Page 1, after the title, add the following section:

## -- RELATED APPLICATION

This application is the non-provisional filing of Provisional Application No. 60/293,738,

filed May 25, 2001, the priority of which is claimed.--

November 6, 2001

Respectfully submitted

William M. Lee, Jr.

Registration No. 26,935

Lee, Mann, Smith, McWilliams,

Sweeney & Ohlson

P.O. Box 2786

Chicago, Illinois 60690-2786

(312) 368-6620

(312) 368-0034 (fax)